## Notice of References Cited Application/Control No. O9/992,186 Examiner OAVID Y. ENG Applicant(s)/Patent Under Reexamination CHANG ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,760,745	07-2004	Tan et al.	709/203
	В	US-6,745,229	06-2004	Gobin et al.	709/206
	С	US-6,697,848	02-2004	Hamilton et al.	709/219
	D	US-6,694,371	02-2004	Sanai, Daiji	709/230
	, E	US-6,477,575	11-2002	Koeppel et al.	709/224
	F	US-6,473,800	10-2002	Jerger et al.	709/226
	G	US-6,366,912	04-2002	Wallent et al.	707/9
	Н	US-6,225,993	05-2001	Lindblad et al.	715/716
	1	US-6,070,185	05-2000	Anupam et al.	709/204
	J	US-6,009,464	12-1999	Hamilton et al.	709/219
	к	US-			
	L	US-			
	М	US-		·	

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	Р					
	Q					
	R					
	S					
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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	<b>V</b>							
	w							
	X							

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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